IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Hisashi ISOZAKI et al.
Title:	SURFACE INSPECTION METHOD AND APPARATUS
Appl. No.:	10/680,432
Filing Date:	10/8/2003
Examiner:	Hoa Q. PHAM
Art Unit:	2877
Confirmation Number:	4198

AMENDMENT AND REPLY UNDER 37 CFR 1.116

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Final Office Action dated January 4, 2007, concerning the above-referenced patent application.

Applicant has enclosed with this amendment a Petition for Extension of Time to make this response timely.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks begin on page 5 of this document.

Please amend the application as follows: